(PW FORM	partm PAT-1	ent of Commerce		P & C	FACE LLVS			Atty. Dkt. No.	M#				Clie	nt Ref.		
			A		F 3/				30	9012			P-18	340.00	0-US	
INFORMATION APPLICA	ON DI	SCLOSURE STA	ATEMĚ	News				Applicant:	Z	AAL et	al. 	_				
								Appln. No.	. 10/8	14,815						
							_	Filing Date	э: Ар	ril 1, 20	04	•				
Date: Sep	temb	er 7, 2004	Page	1	of	4	<u> </u>	Examiner:	Unk	nown		Gro	up Art U	nit: 26	#2 28	5/
U.S. PATEN	DOC	CUMENTS				······						,			Υ	
Examiner's							Class	s Sub Class		Filing Date (if appropriate)						
Initials*		Number		MM/Y				First Inver	itor)			447			(if appropriate)	
D.R.	AR	3,573,975		04/19		DHAKA 6						117	212		 	
 	BR	3,648,587		03/19		STEVENS						95 430	311		 	
	CR	4,346,164		08/19		TABAREL						355	125		-	
	DR	4,390,273		06/19		AKEYAM						430	326		<u> </u>	
	ER	4,396,705		11/19		TAKANAS						355	30		 	
	FR	4,480,910		-		Tabarelli e		<u> </u>		 		355	30		1	
-	GR HR				RAUSCHI		TH et el				355	53				
	IR	5,040,020 5,121,256						JI I GC 01.				359	664			
 	JR	5,610,683		06/1992 CORLE et al. 03/1997 TAKAHASHI								355	53		 	
 	KR	5,715,039		02/19		FUKUDA						355	53			
-	LR	5,825,043		10/1998 SUWA								250	548			
									395		ļ —					
D.R.								548		 						
FOREIGN PATENT DOCUMENTS									English A	bstract	Translatio	n on				
FUNEIGNE	TEN	Document-	Date		Count	rv	Inven	tor Name		1					Readily Available	
		Number	MM/Y	ſΥΥ		.,									Available	
													Enclosed	No	Enclosed	No
D.R.	OR	WO 99/49504	09/199	9	PCT		Fuka	mi <i>et al</i> .					Х		X	
	PR	EP 0023231	02/198	31	EURC	PE	TABA	RELLI et a	ıl.				Х			
	QR	EP 0418427	03/199	91	EURC	PE	MIYA	KE					Х		Х	
	RR	EP 1039511	09/200)O ·	EURC	PE	MUR	AKAMI et a	ıl.				Х		X	
	SR	DD 224448	07/198	35	GERN	MANY	HESS	SE et al.	•					Х		
	TR	DD 242880	02/198	37	GERN	IANY	KUC	1						X		
	UR	FR 2474708	07/198	31	FRAN	CE	LETE	LLIER						X		
	VR	JP 62-065326	03/198	37	JAPA	N	MOR	IUCHI					Х			
	WR	JP 62-121417	06/198	37	JAPA	N	NAKA	AZAWA					X			
	XR	JP 63-157419	06/198	38	JAPA	N	NAKA	ASUJI					×			丄
	YR	JP 04-305915	10/199	2	JAPA	N	OZE	KI et al.					X		<u> </u>	
<u></u>	ZR	JP 04-305917	10/199	92	JAPA	N	OZE	KI et al.			<u> </u>		X			$oldsymbol{\perp}$
D.R.	AAR	JP 06-124873	05/199	14	JAPA	N	TAKA	HASHI				· · · · · · · · · · · · · · · · · · ·	X		x	
OTHER (Incl	uding	in this order Auth	nor, Title	e, Perio	dical N	Name, Date	e, Perti	nent Pages	s, etc	.)						
DR	BBR	M. SWITKES et December 17, 2		mersio	n Litho	graphy at 1	157 nm	n", MIT Linc	oin L	ab, Orl	ando 20	001-1,				
DR	CCR	M. SWITKES et No. 6, Novembe	al., "lm					n", J. Vac. S	Sci. T	echnol.	B., Vol	. 19,				
DR	DDR	M. SWITKES et	al., "Im					r the 50 nm	n Nod	le", 157	Anvers	s-1,				
	QZ,	September 4, 20	-					Data Casa	ida	d.	11/-	2 4	~~	<u></u>		<u> </u>
*EXAMINER:	پدست	~	nsider	d who	ther o	not citatio	n ie in	Conforman				2/ <u>/</u>	w line th		citation	if
	*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.															

FORM PTO-1449 (modified) To: U.S. Department of Commerce (PW FORM PAT-1449) Patent and Trademark Office									Atty. Dkt. No.	M#		Clien	t Ref.		
'	4.0								•			- 2 42			
									A = = 1 = = = 4 :	309012		P-18	<u> 10.00</u>	0-US	
	RMATI PPLICA		SCLOSURE STATEM	ENT					Applicant:	ZAAL et al.					
-									Appln. No.	10/814,815					
										: April 1, 2004					
Date	: Septe	mber 7	7, 2004	Page	2	of	4		Examiner:		Grou	up Art Un	it: ` 2 8	12 28	5
U.S.	PATEN	T DOC	UMENTS												
Exan	niner's		Document		Date	Date Name					Class			Filing D	
Initia	ls*		Number		MM/YY	ΥY	(Family Nan	ne o	of First Inve	entor)		Class	<u>; </u>	(if appropriate)	
D	\mathcal{R}_{\perp}	AR	6,560,032	_	05/2003	3	HATANO				359	656			
		BR	6,600,547		07/2003	3	WATSON 6	t al.							
		CR	6,603,130		08/2003	3	BISSCHOP	S e	t al.		250	492.1		<u> </u>	
<u> </u>		DR	6,633,365		10/2003	3	SUENAGA				355		53		
\square		ER	2002/0163629		11/2002	<u>.</u>	SWITKES 6	t al			355	53		ļ	
		FR	2003/0123040		07/2003 ALMOGY						355	69			
		GR	2003/0174408		09/2003	3_	ROSTALSK	l et	al.		359	642	642		
		HR	2004/0000627 A1 01/2004 SCHUSTER												
		IR	2004/0021844 A1 02/2004 SUENAGA							_					
	/	JR	2004/0075895 A1 04/2004 LIN						359	380					
$\perp \mathcal{I}$	<u>).R.</u>	KR	2004/0109237 A1 06/2004 EPPLE et al.							<u> </u>					
IFOREIGN FATERI DOGUNENTO									Translatio Readily	n					
		Document Date				e Country In			nventor Name					Available	
		ŀ	Number	MM/	YYYY			١,	•				1		1
	(a)	<u> </u>						_				Enclosed	No	Enclosed	NO
1	<u>.R.</u>	LR	JP 07-220990	08/19			PAN	-	KUDA et a	<i>I</i> ,		X	┼		⊢
\vdash	ļ	MR	JP 10-228661	08/19							X	┼		├	
<u> </u>		NR	JP 10-255319	09/19		_	PAN	1	ENAGA et	al.		X	₩	 	┼
		OR	JP 10-303114	11/19			PAN	1	IWA			X	┼—	X	├-
<u> </u>		PR	JP 10-340846	12/19			PAN	1	DO			X	—	X	┼
	· · ·	QR	JP 2001-091849	04/20			PAN	1	ZAKI et al.			X	₩	-	\vdash
 		RR	JP 07-132262	05/19			oan	+	RAKAWA e			X	₩		┼
<u> </u>		SR	JP 58-202448	11/1		_	oan	 	WAMURA			X	┼	 	₩
		TR	WO 2004/019128	03/2		$\overline{}$	T ·	† -	MURA et al.			X	+-	X	\vdash
1	D	UR VR	WO 03/077037 WO 03/077036	09/2		PC PC		t	OSTALSKI (CHUSTER	et al.		X	+-	X	╁
	· / / /	4				_		_		4.Danas (ata.)		<u> </u>	┿	 	-
OTH	IER (In	1	in this order Autho					-					┼─	-	╁
$ \mathcal{I} $) R.	WR	B.J. LIN, "Drivers, Pr September 2002	osped	as and C	,na	ilenges for il	*1111	ersion Lime	graphy , 15MC, in	٠.,]
,		XR	B.J. LIN, "Proximity F No. 11B, April 1978,			gh l	Liquid", IBM	Tec	chnical Disc	closure Bulletin, Vol	.20,				
 		YR	B.J. LIN, "The Paths			icro	meter Ontic	al I	ithography'	SPIE Vol. 922		 	1		\vdash
			Optical/Laser Microli												
		ZR	G.W.W. STEVENS, Technology, August					g fr	om Mask D	efects", Solid State					
		AAR	S. OWA et al., "Imme Microlithography 200	ersion	Lithogra	ph	y; its potenti		erformance	and issues", SPIE					
I	12	BBR	S. OWA et al., "Adva (2003)	-				_	on Lithogra	phy", Proc. SPIE 50	40				
Exan	niner	(Q),	Meds			-			Date Cons	idered: /// o	,/	05		1	
			7	red. v	vhether o	ם ח	ot citation is	_					ough	citation	if
	EXAMINER: Inital if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if of in conformance and not considered. Include copy of this form with next communication to Applicant.														

FORM PTO-1449 (modified) To: U.S. Department of Commerce (PW FORM PAT-1449) Patent and Trademark Office						Atty. Dkt. No.	M#				Ctie	nt Ref					
										30	90	12		P-18	40.00	00-US	
1 .	RMATI	-	ISCLOSURE STATEM	ENT					Applicant:	ZA	AL	et al.					
									Appln. No.	10/8	814	,815					
						,		_	Filing Date	: Ap	linc	1, 2004					
Date	: Septe	mber	7, 2004	Page	3	of	4		Examiner:	Unk	kno	wn	Grou	up Art Ur	nit: 2	##78	<u>57</u>
U.S.	PATEN	T DO	CUMENTS													т	
1	xaminer's Document Date Name											Class	Sub Clas		Filing D		
Initial		1	Number				(Family Na	me (of First Inve	entor)		200			(if approp	nate)
14	<i>R.</i> _	AR	6,236,634 B1		05/200		LEE et al.		1 -4 -1				369	112		 	
1). <u>Z.</u>	BR	2002/0020821 A1	I	02/200	2	VAN SAN	IF	v et al.	x			250	492		 	
FOR	EIGN P	ATEN	T DOCUMENTS	1		I_		Т.			- 1			English Al	ostract	Translation Readily)N
		ļ	Document	Date MM/Y	VVV	Co	untry	linv	rentor Nam	е						Available	
1		İ	Number											Enclosed	No	Enclosed	No
7	D	CR	DD 206 607	02/19	0.4	GE	RMANY	10/1	ESTPHAL 6	1 0				Liicoseo	X	Elicioseo	+
4	1	DR	DD 221 563	04/19		<u> </u>	RMANY	+		al.	\vdash				 ↑	 	+
	 	ER	JP 11-176727	07/19					FORR et al.					×	 ^	╁──	十
		FR	JP 2000-058436	02/20		-	PAN		shima et al.				×	+-	+	+	
-		GR	*	06/20					VA					×	+-	+	+
		HR	WO 2004/053951 A1						GOME et a	al l				X	+	+	+-
		IR	The state of the s	06/20					AGOME et al.				- 17	×	1		+-
		JR		06/20					et al.		\dashv			X	+	†	+
_		KR	†	06/20	-	PC		l et al.					X	1-	+	十	
		LR	WO 2004/053955 A1			_			RUKAWA e	t al.	ᅥ		-	X	+-	†	+
	<u> </u>	MR	 	06/20		 		GASAKA e					X	+-	 	1	
		NR	2-	06/20	04	PC	T	1	DAKA et al.					X			T
		OR	WO 2004/053958 A1	06/20	04	PC	T	MI	ZUTANI et	al.			-	Х	†		\vdash
1		PR	WO 2004/053959 A1	06/20	04	PC	T	SH	IIRAI		Ť			X	1		\top
D	\mathcal{R}	QR	WO 2004/053596 A2	06/20	04	PC	T	GR	RAUPNER	-				X			1
		ludir	g in this order Autho	r. Title	Perio	dic	al Name [ate	Pertinen	t Pa	ne	s etc.))	1	† 	T
I)A.		Nikon Precision Europ 2003										,				
		SR	H. KAWATA et al., "O Greater than Unity", M								Nur	nerical Aper	tures				
		TR	J.A. HOFFNAGLE et a J. Vac. Sci. Technol. E	al., "Lic	uid Imr	ner	sion Deep-L	Iltra	violet Interf	eron	neti	ric Lithograp	hy",		1		T
		UR	B.W. SMITH et al., "Im	nmersi	on Optio	cal									<u> </u>		T
		VR	H. KAWATA et al., "Fa	International, Vol. 15, July 11, 2003 H. KAWATA et al., "Fabrication of 0.2µm Fine Patterns Using Optical Projection Lithography with an Oil Immersion Lens", Jpn. J. Appl. Phys. Vol. 31 (1992), pp. 4174-													
		WR	G. OWEN et al., "1/8µ November/December					ic. S	Sci. Techno	l. B.,	Vo	l. 10, No. 6,		"		<u> </u>	
	/	XR	H. HOGAN, "New Sen Photonics Technology	nicond	uctor Li	tho	graphy Mak			нот	TOP	NICS SPECT	ſRA,				
\mathcal{D}	\mathcal{R}	YR	S. OWA and N. NAGA Lithography", NGL Wo	SAKA	, "Poter	ntial	Performano	ce a	nd Feasibil		f In	mersion					
Exam	iner X	QL,	Heals				,		Date Consi		.d.	11/		11	/\rac{1}{\rac{1}{2}}	<u></u>	
*EXA	MINER:	ا	nitial if citation conside	red, w	hether o	or n	ot citation is	in c	conformanc	e wi	th N	MPEP § 609	. Drav	w line the	ough	citation	if
not in	conform	nance	and not considered. It	nclude	сору о	f thi	is form with	nex	t communic	atio	n to	Applicant.					

, •,						Atty. Dkt. No.	M#				Client	Ref.					
												\dashv	D 404	2 00	2112		
	-							Applicant:	3090				P-184	0.00	0-08		
BY APPLICA		SCLOSURE STATEM	ENI					Аррисант:	ZAAL	et ai.							
								Appln. No.	10/814	,815							
•	Filing Date: April 1, 2004																
Date: Septe	mber	7, 2004	Page	4	of	4	<u></u>	Examiner:	Unkno	wn	Gro	up A	rt Unit	: 22	±2 28	<u>'5/</u>	
U.S. PATEN	T DOC										1	- 1					
Examiner's	i	Document		Date		Name					Class				Filing Date		
Initials*		Number		1		(Family Nar			ntor)			-	Class	SS (if appropria		riate)	
D.R.	-	2004/0119954		06/200		KAWASHI					355	$\overline{}$	30		 -		
D.K.		2004/0125351		07/200)4	KRAUTSC	HII	K et al.			355		53		· -		
	BBR			<u> </u>							ļ				<u> </u>		
	CCR							·			ļ						
	DDR			ļ								_					
	EER										<u> </u>						
	FFR											_					
	GGR										<u> </u>						
	HHR										<u> </u>						
FOREIGN PA	ATEN	T DOCUMENTS										Engi	ish Abs	tract	Translatio	'n	
				lnv	entor Name	9			1			Readily Available					
	·	Number ·	MMA	YYYY				•									
												Enci	osed	No	Enclosed	No	
D.R.	IIR	WO 2004/055803 A1	07/20	004	PC	T	VA	N SANTEN	<u> </u>			×	`		X	丄	
	JJR	WO 2004/057589 A1	07/20	004	04 PCT NE			IJZEN et al.				X	<u> </u>		X		
1	KKR	WO 2004/057590 A1	07/20	004	04 PCT VAI			N SANTEN et al.				<u> </u>	(x	上	
DR	LLR	JP 2004-193252	07/20	004	Ja	pan	No	ot Available				<u> </u> x		L	L	<u></u>	
	MMF]										
	NNR						<u> </u>	•									
	OOR												_				
	PPR												Ì				
OTHER (Inc	ludin	g in this order Autho	r, Titl	e, Perio	odic	al Name, D	ate	e, Pertinen	t Page	s, etc.)		Π				Т	
D2.		S. OWA et al., "Updat SEMATECH, Los Ang	e on 1	193nm ir	mm	ersion expos	sure	tool", Litho			nal]					
	RRR	H. HATA, "The Develo SEMATECH, Los Ang							Forum	, Internation	al						
	SSR	T. MATSUYAMA et al 5377-65, March, 2004		on Proje	ectio	on Lens Upd	ate	, SPIE Mic	rolithog	raphy 2004	,						
	TTR	"Depth-of-Focus Enha IBM Technical Disclos	ncem							Imaging La	yer*,						
	UUR	A. SUZUKI, "Lithograp 2004			_					mes, Januai	y 5,						
DR.	₩R	B. LIN, "The k ₃ coeffice focus, and immersion															
	ww											T				\top	
	XXR														f	T	
	YYR															\top	
	ZZR	·														 	
	AAA	-										T				T	
Examiner	A)/	tack		<u></u>				Date Consi	idered:	.11/0	/	0	ــــــــــــــــــــــــــــــــــــــ			<u></u>	
*EXAMINER:	1	nitial if citation conside	red v	vhether	or n	ot citation is								uah	citation	if	
		and not considered. I												-3			

PATENT APPLICATION

Docket Number: 081468-03090 12 Client Reference: P-1840.000-US

P-1840.000-US 34. 4 . 2

IN THE UNITED STATES PASENT AND TRADEMARK OFFICE

In Re the Application of

ZAAL et al.

٠١.

Group Art Unit: 2812

Application No.: 10/814,815

Examiner: Unassigned

Filed: April 1, 2004

Confirmation No.: 5302

For: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

September 7, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. 1.56, the attention of the Patent and Trademark Office is hereby directed to the following U.S. patent application(s):

2,07	Examiner's Initials	First Inventor	Application No.	Filing Date	Enclosed
. 5 m		DE SMIT (081468-0309173)	10/820,227	04/08/2004	SpecificationDrawings
	D.R.				☑ Other: stamped receipt card
		DE SMIT (081468-0309978)	10/860,662	06/04/2004	☑ Specification☑ Drawings☑ Other: stamped receipt card
Ŋ		DUINEVELD et al. (081468-0308101)	10/773,461	02/09/2004	☑ Specification☑ Drawings☑ Other: stamped receipt card
D Nox		FLAGELLO et al. (081468-0302644)	10/698,012	10/31/2003	☑ Specification☑ Drawings☑ Other: stamped receipt card
'n×		DE SMIT et al. (081468-0306530)	10/705,804	11/12/2003	Specification Drawings Other: stamped receipt card
		LOF et al. (081468-0306781)	10/705,805	11/12/2003	☑ Specification☑ Drawings☑ Other: stamped receipt card
	D.R.	LOF et al. (081468-0306524)	10/705,783	11/12/2003	☑ Specification☑ Drawings☑ Other: stamped receipt card

30477676v1

,	Examiner's	First Inventor	Application	Filing	Enclosed
	Initials		No.	Date	
	APE	VAN SANTEN et al.	10/743,271	12/23/2003	Specification ■ Control of the control
		(081468-0307331)			☐ Drawings
•	See 1 mm H				☑ Other: stamped receipt card
2,3	3 8	MULKENS et al.	10/743,266	12/23/2003	Specification ■ Control of the control
P	TO TO WEEK	(081468-0307333)	·		☑ Drawings☑ Other: stamped receipt
Review D. R.					card
- Comment	,	DERKSEN et al.	10/705,785	11/12/2003	Specification
5.8°5.4		(081468-0306526)			☑ Drawings☑ Other: stamped receipt
•					card
		SIMON et al.	10/724,402	12/01/2003	Specification
		(081468-0307087)			☑ Drawings☑ Other: stamped receipt
					card
		BLEEKER (081468-0306527)	10/715,116	11/18/2003	☒ Specification☒ Drawings
		(001400-0300327)	\		☑ Other: stamped receipt
^		OTDEECKEDIK 1	10,500	44/04/0000	card
Q_{α}		STREEFKERK et al. (081468-0306882)	10/719,683	11/24/2003	☒ Specification☒ Drawings
1		(001.100.00000_	,	,	Other: stamped receipt
		LOF et al.	10/705,816	`1,1/12/2003	card Specification
Z) '		(081468-0306525)	10/705,616	1/1/2/2003	☐ Specification ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐ ☐
^					Other: stamped receipt
DO NOT TOX		DIERICHS	10/775,326	02/11/2004	card ⊠ Specification
		(081468-0308270)	10/11/0,020	02200.	⊠ Drawings
)	Other: stamped receipt
		LOF et al.	10/857,614	06/01/2004	⊠\Specification
•	.	(081468-0309957)	·		
					☑ Other: stamped receipt card
•		SUWA et al.	10/367,910	02/19/2003	
:		(Reissue Application of U.S. Patent No. 6,191,429			☑ Drawings ☐ Other: stamped receipt
:		B1)			card
			40/000 777	0.4/4.4/000.4	⊠ Consideration
		KOLESNYCHENHO et al. (081468-0309196)	10/823,777	04/14/2004	☒ Specification☒ Drawings
	1777				Other: stamped receipt
	V./				card

*The Examiner's initials adjacent a citation indicates he/she has considered the cited application relative to the subject application.

It is respectfully requested that these applications and the art cited therein during examination be expressly considered during the prosecution of this application and be made of record in this application. The identification of the above U.S. patent applications is not to be construed as a waiver of secrecy as to those applications now or upon issuance of the present application as a patent.

<u>PLEASE DO NOT PRINT</u> the above information on the patent which results from this application.